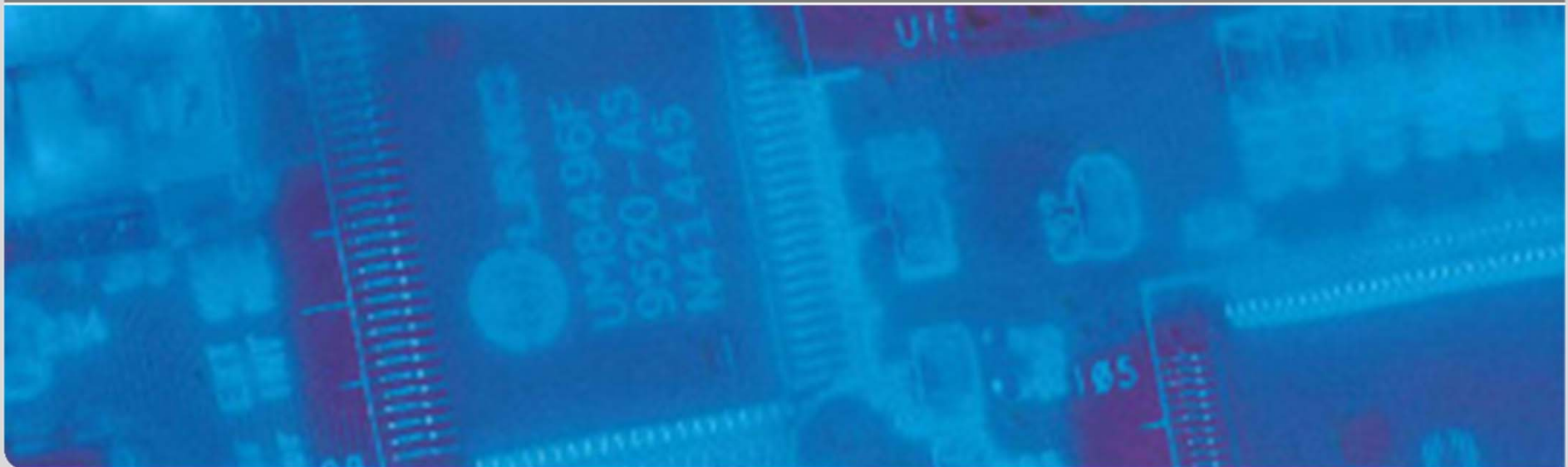


Integrierte Intelligente Sensoren Sommersemester 2012

27.06.2012

Wilhelm Stork

Institut für Technik der Informationsverarbeitung (ITIV)



Laserradar

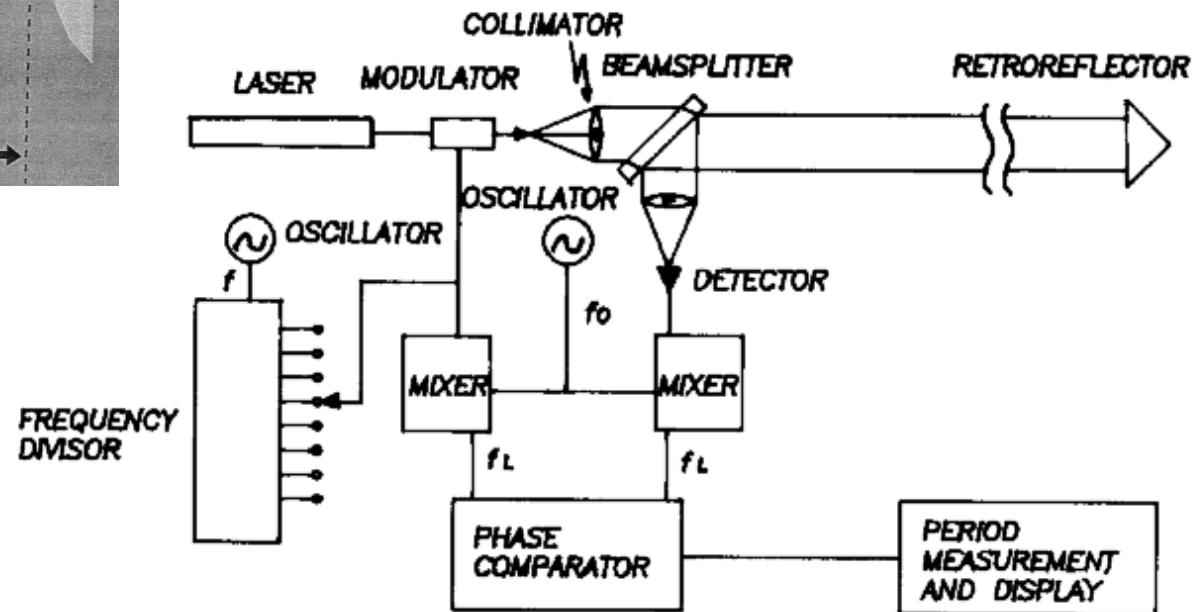
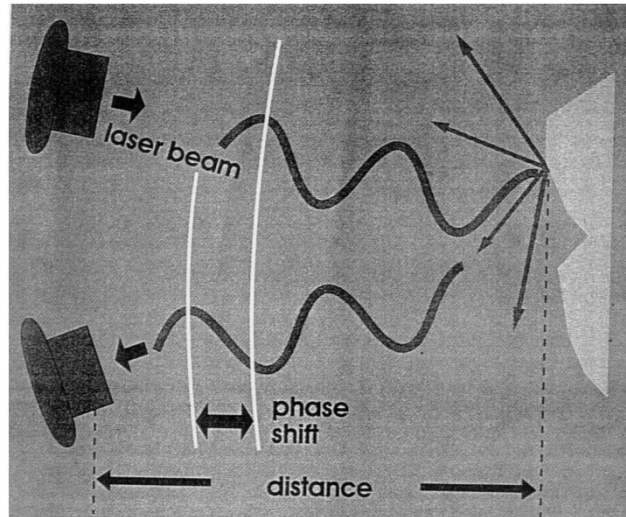


FIGURE 4 A wave modulation distance meter.

Systemüberblick – Phasenmessprinzip

■ Phasenverschiebung

$$\Delta\varphi = 2\pi \left(f \cdot \frac{2D}{c} + n \right)$$

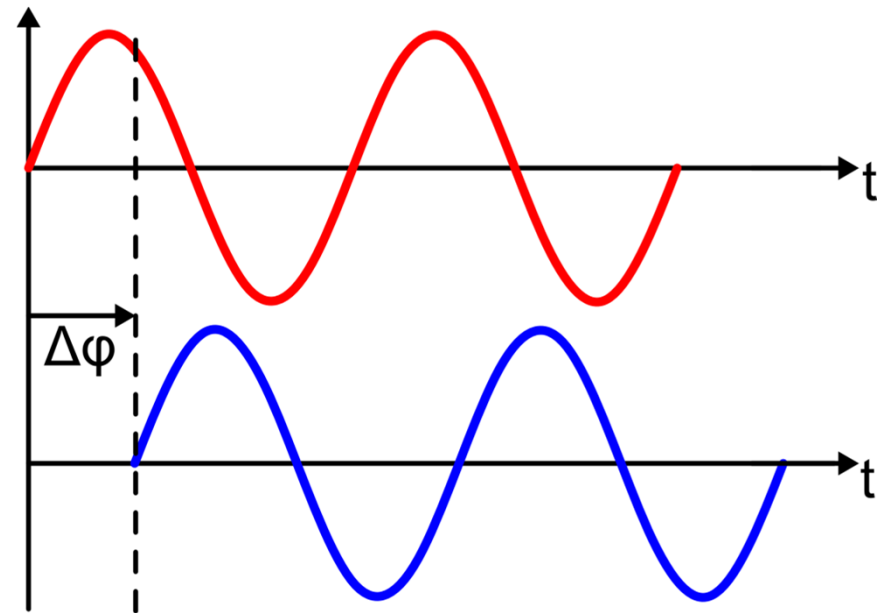
■ Eindeutigkeitsbereich

$$D_{\max} = \frac{c}{2f}$$

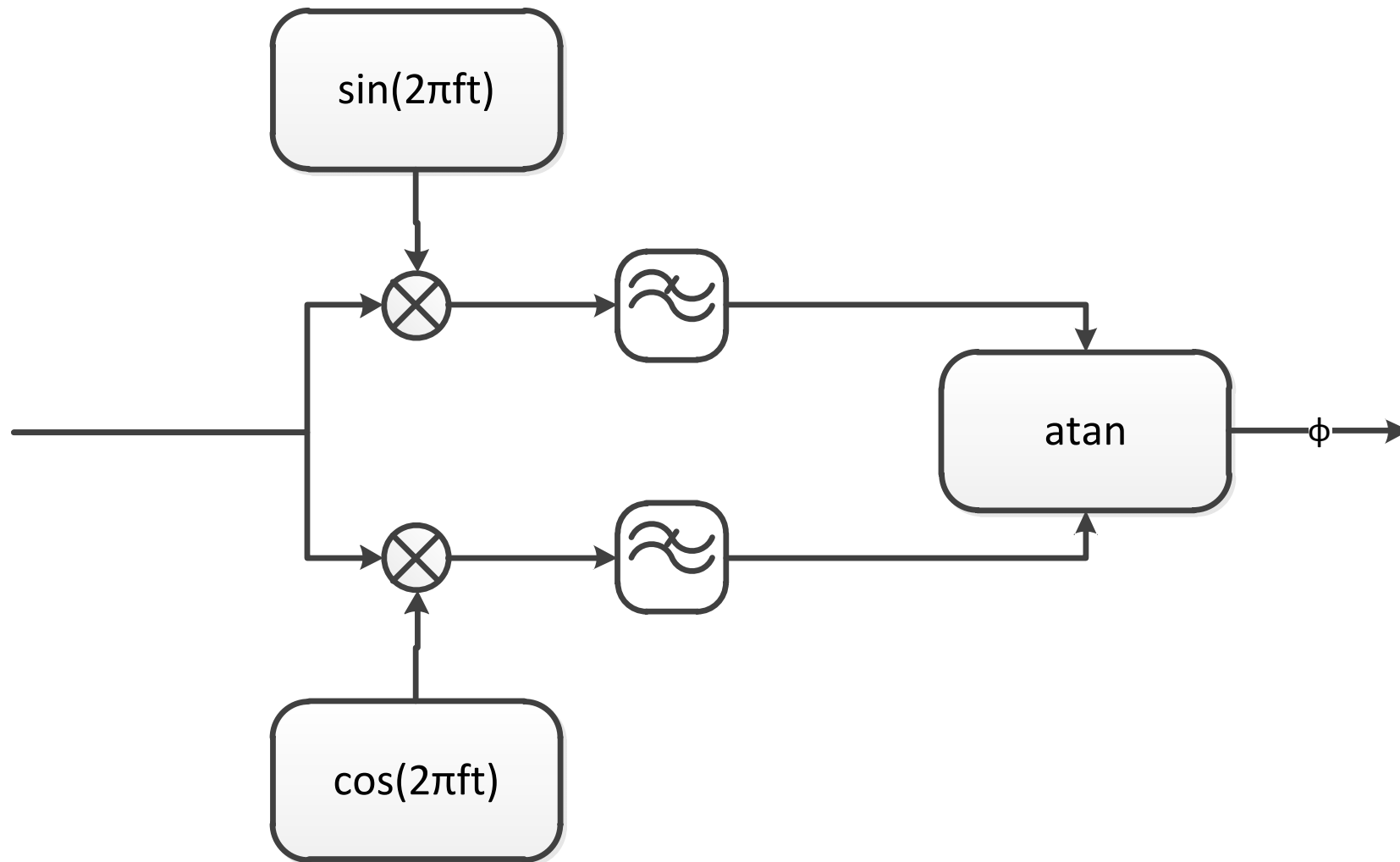
$$f_1 = 5\text{MHz} \rightarrow D_{\max} = 30\text{m}; \quad f_2 = 100\text{MHz} \rightarrow D_{\max} = 1.5\text{m}$$

■ Phasenauflösung

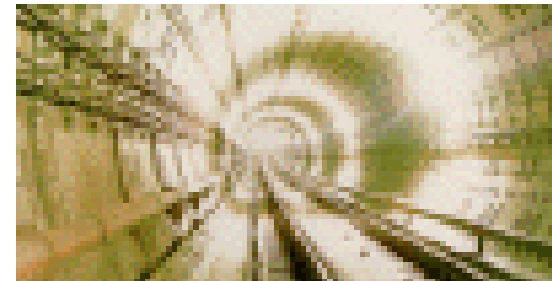
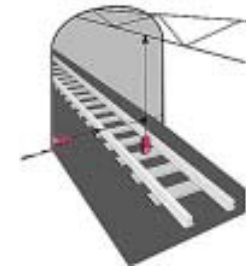
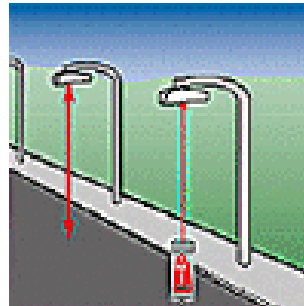
$$d\varphi = 2\pi \cdot \frac{dD}{D_{\max}} = 2\pi \cdot \frac{2\text{cm}}{30\text{m}} = 2\pi \cdot \frac{1\text{mm}}{1.5\text{m}} \cong 4\text{mrad}$$



Messprinzip – IQ-Demodulator

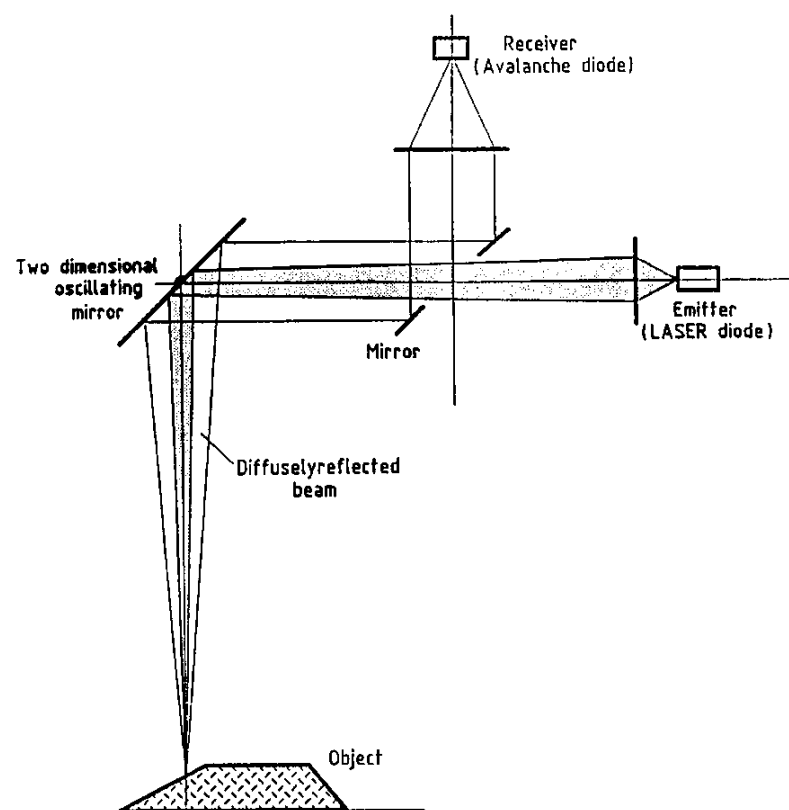


Laserradar

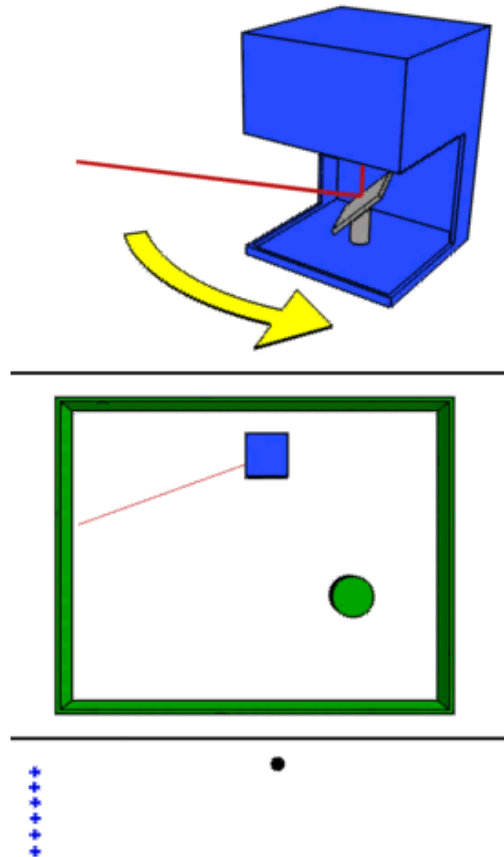


Automatische Deformationsmessungen in einem Tunnel

Laserradar mit Feld für 3D Messung



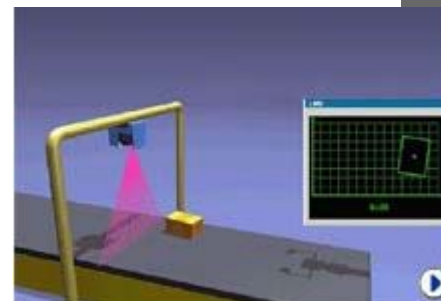
Laserradar mit Drehspiegel



Faro 3D Scanner mit ITIV Signalverarbeitung



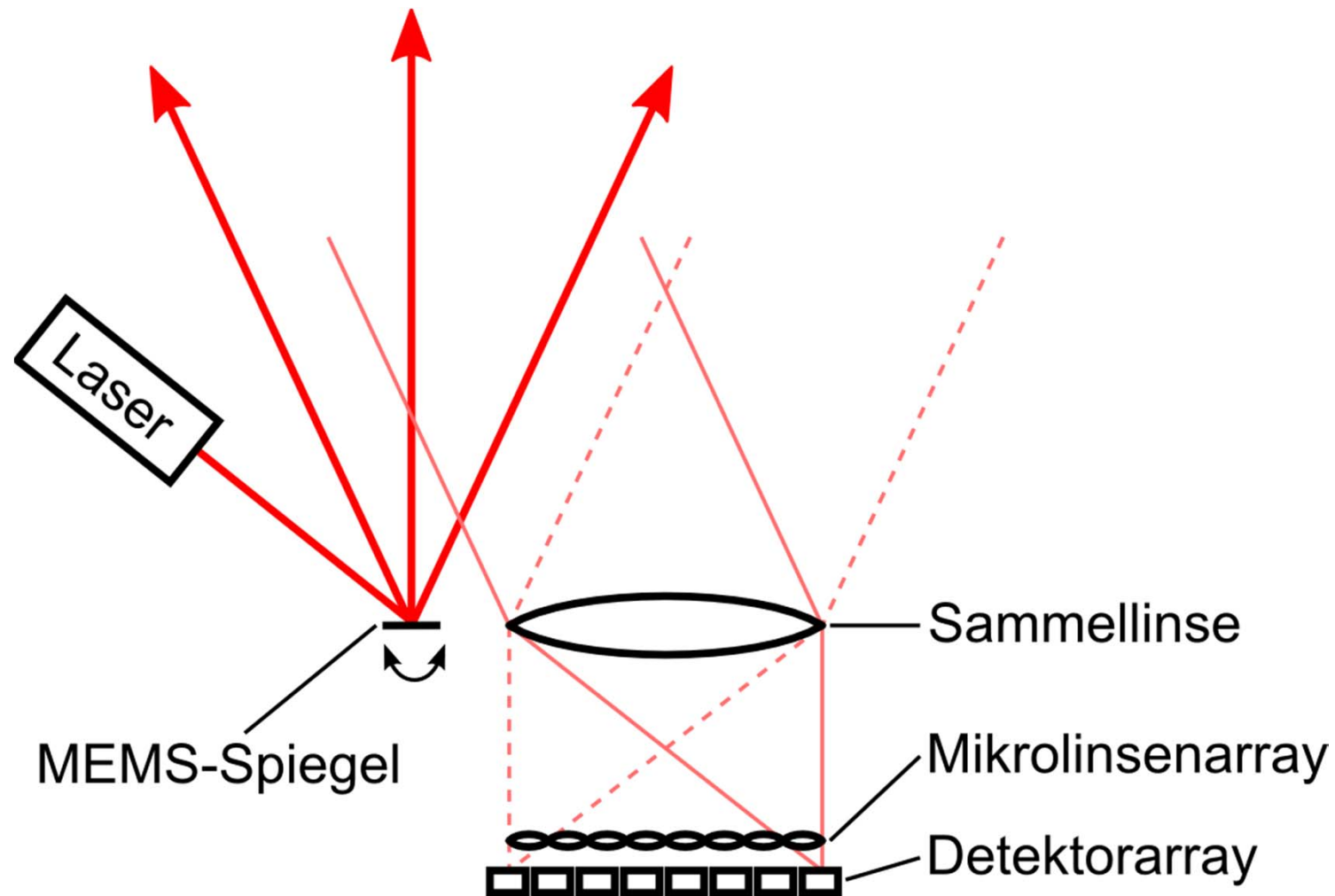
Sick Laser Scanner



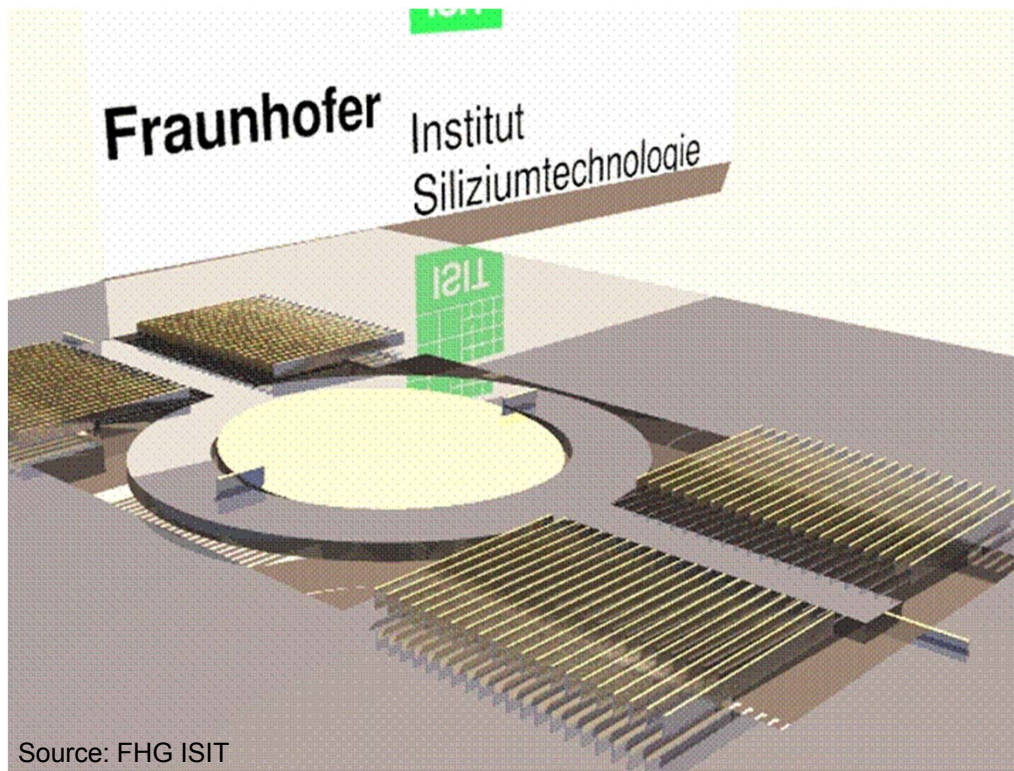
Fahrerlose Transportsysteme



Systemüberblick – Optischer Aufbau Sari



Stand der Technik – Scannende MEMS Mikrospiegel

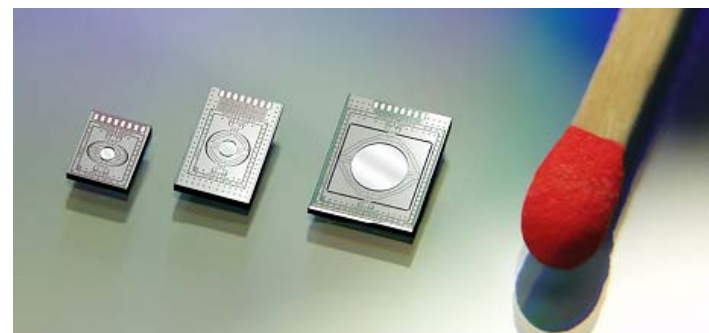
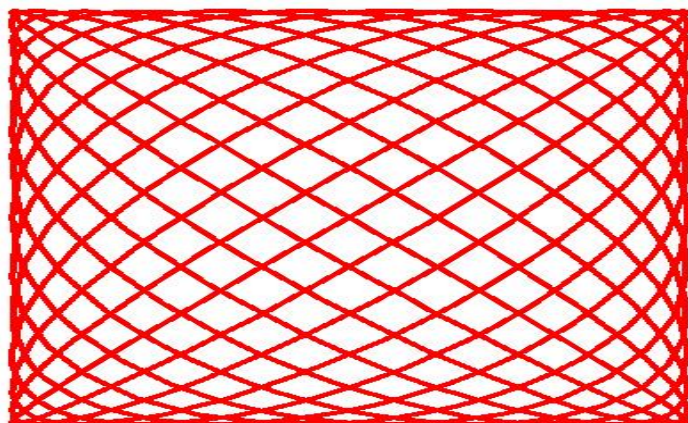


- 2-Achsen Scan
- $f_{\text{res}} \approx 20 \text{ kHz}$
- Spiegelgröße: $\varnothing \approx 1 \text{ mm}$
- Hohe Stoßfestigkeit ($> 2000g$)
- Electro-statisches Antriebsprinzip

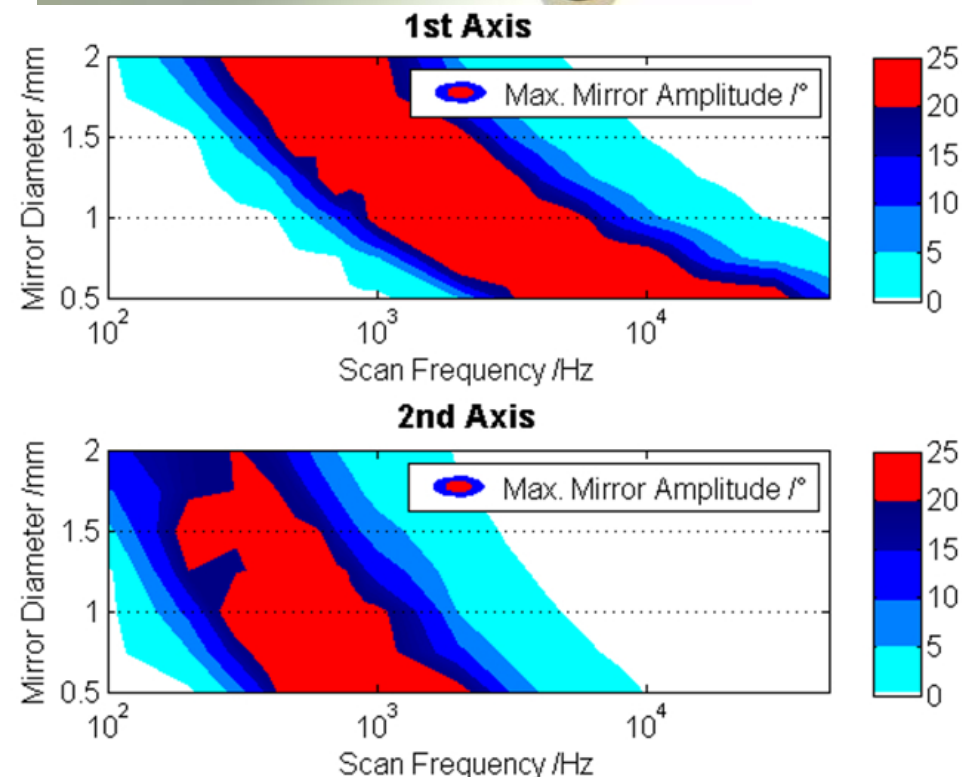
Stand der Technik – Elektrostatische Mikrospiegel

Parameter	Wertbereich
Spannung	0...100V
Resonanzfrequenz	0.1...40kHz
Max. Auslenkwinkel	+/-60°
Durchmesser	0.5...3mm

- Resonanzfrequenzen voneinander abhängig

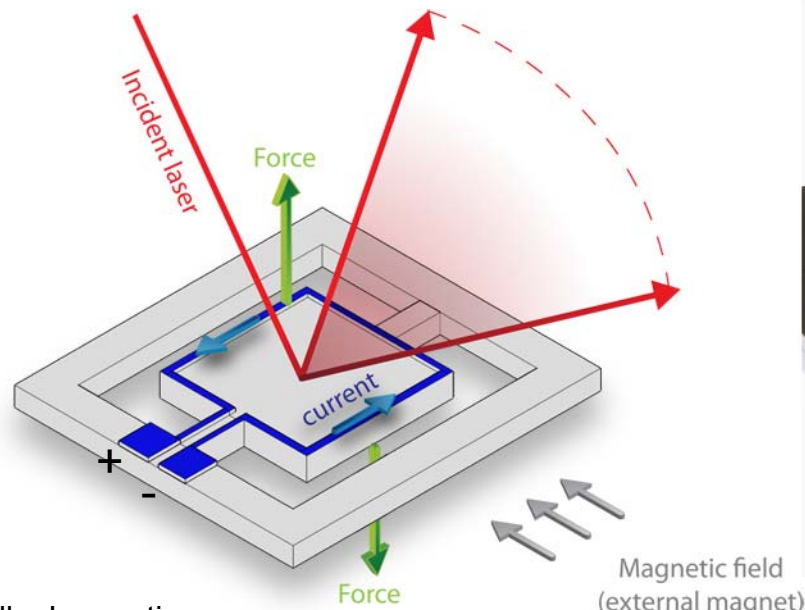
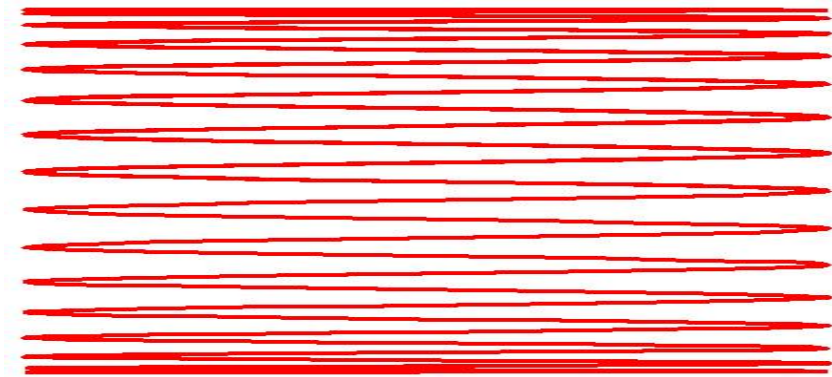


Quelle:
Fraunhofer
IPMS

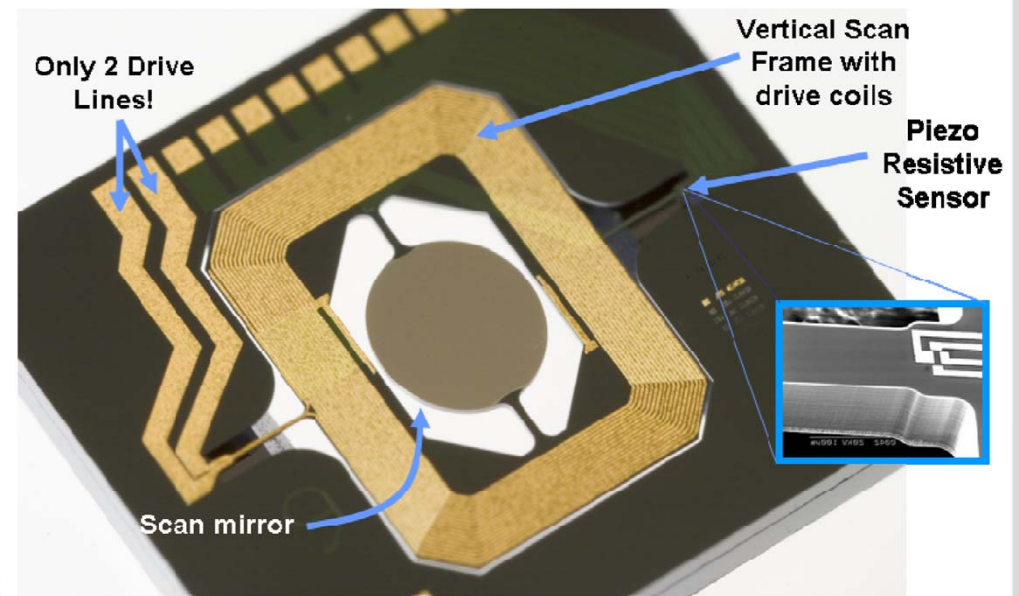


Stand der Technik – Elektrodynamische Mikrospiegel

Parameter	Wertbereich
Spannung	0...5V
Resonanzfrequenz	1...25kHz
Max. Auslenkwinkel	+/-17.5°
Durchmesser (typ.)	1mm



Quelle: Lemoptix



Quelle: Microvision

Stand der Technik – Mikrospiegel im Vergleich



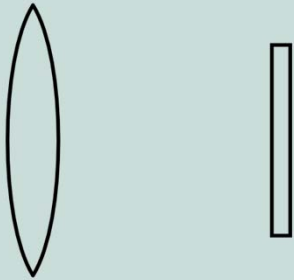
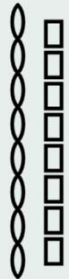
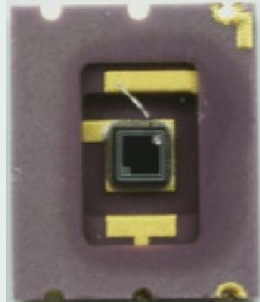
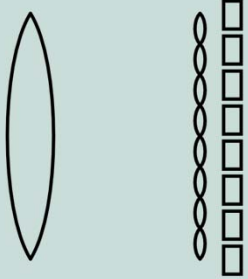
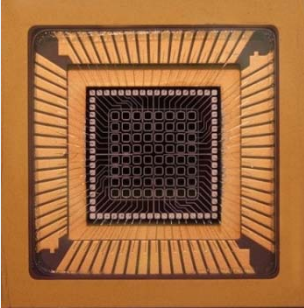
Source: Microvision, Inc.



Source: FHG IPMS

	Elektro-dynamisch		Elektro-statisch	
Anregung	Elektro-magnetisch		Elektro-statisch	
2-Achsen-Scan	Ja (noch nicht erhältlich)	-	Ja	+
Scanwinkel	+/- 17.5°	-	+/- 60°	+
Anz. Hersteller	2 (Vertrieb nur 1)	-	> 5	+
Spannung	0...5V	+	0...100V	-
Scantrajektorie	Zeilenscan	+	Lissajous-Figur	-

Mögliche Detektor-Konzepte

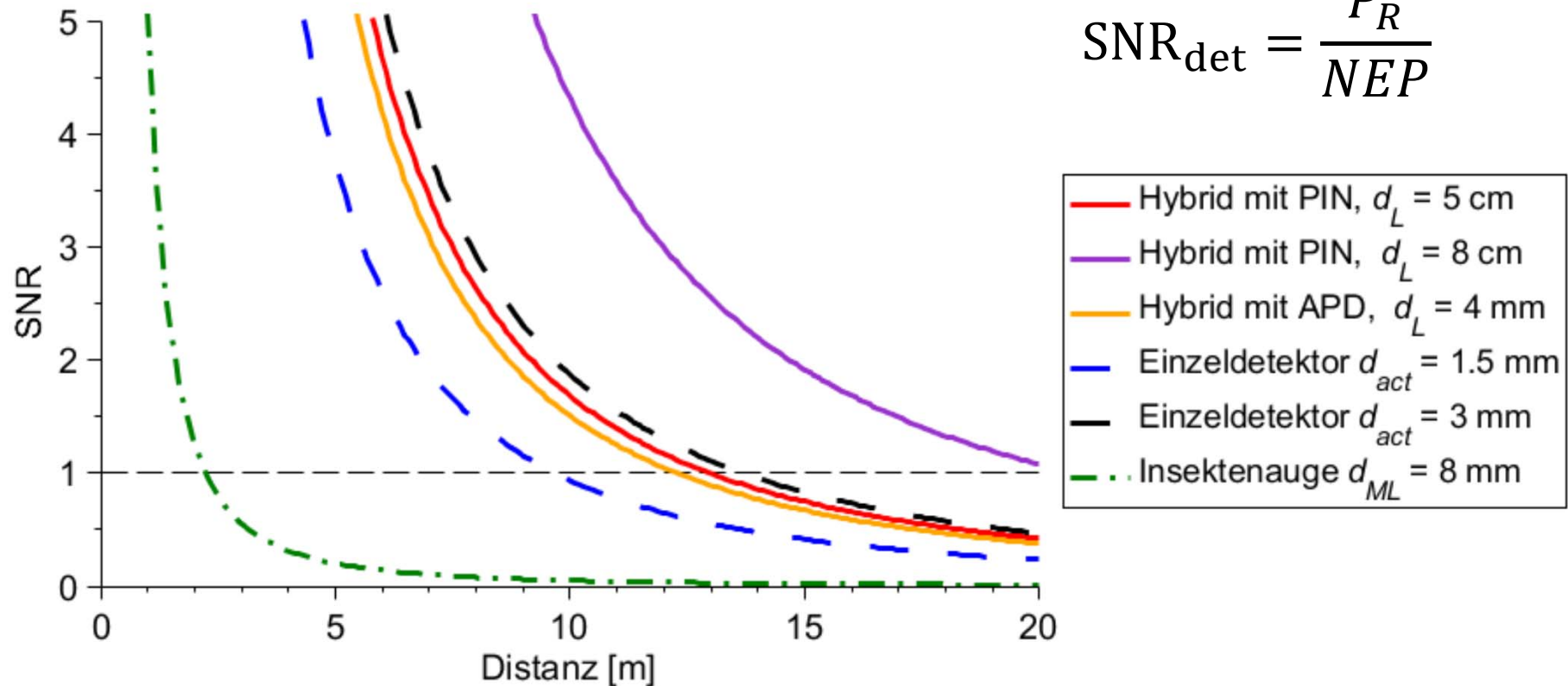
Detektorkonzept	Aufbau	Verwendeter Detektor
1. Einzeldetektor		- Avalanche Photodiode - Akt. Fl.: $\varnothing = 3\text{mm}$ $f_{\text{Cutoff}} = 80\text{ MHz}$ $\text{NEP} \approx 0.4\text{pW/Hz}^{1/2}$ 
2. Insektenauge		- Array aus PIN-PD - Akt. Fl.: $1\text{x}1\text{mm}$ $f_{\text{Cutoff}} = 350\text{ MHz}$ $\text{NEP} \approx 0.35\mu\text{W/Hz}^{1/2}$ 
3. Hybrid		- APD-Array (8x8) - Akt. Fl.: $200\text{x}200\mu\text{m}$ $f_{\text{Cutoff}} = 175\text{ MHz}$ $\text{NEP} \approx 0.3\text{pW/Hz}^{1/2}$ 

SNR-Abschätzung – Detektorrauschen

Parameter	Wert
Laserleistung P_S	300mW
Reflexionsgrad ρ_{FI}	10%
Anzahl Detektoren (Hybrid)	9x9

$$P_R = \frac{\rho_{FI} d_L^2}{4D^2} \cdot P_S$$

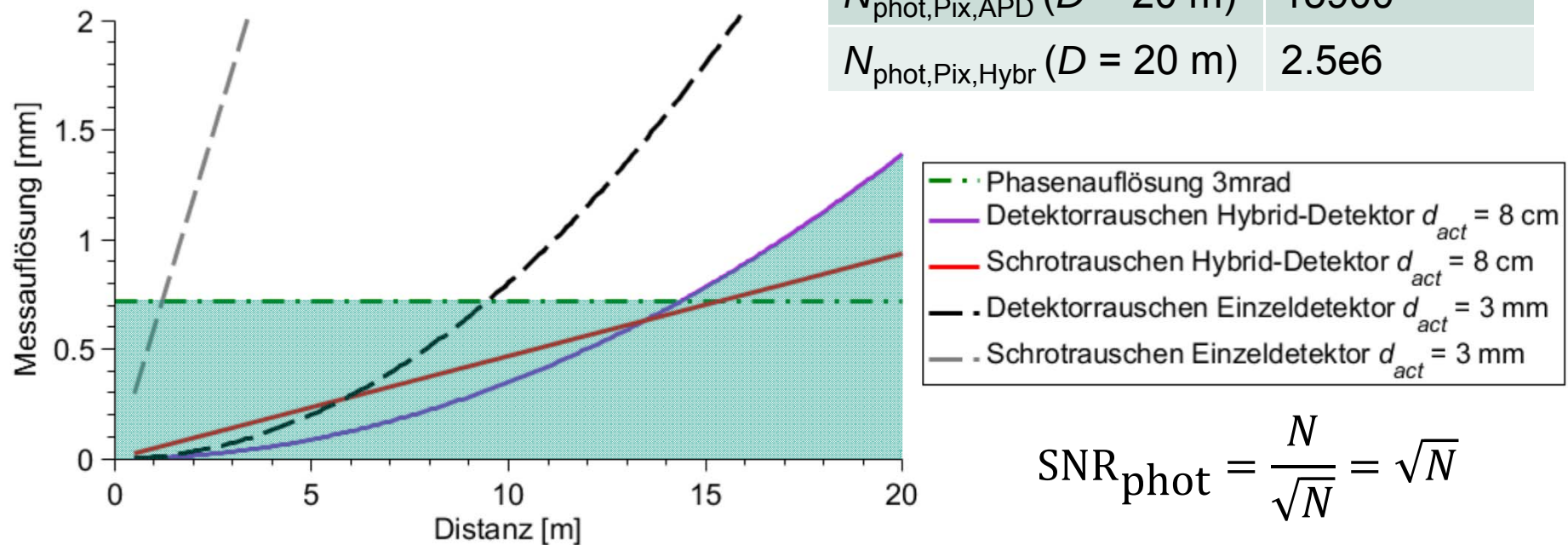
$$\text{SNR}_{\text{det}} = \frac{P_R}{NEP}$$



Erreichbare Messauflösung – Schrotrauschen

- Einzeldetektor durch Schrotrauschen begrenzt
- Hybrid-Detektor durch Detektorrauschen begrenzt

Parameter	Wert
Auflösung (Pixel)	100x100
f_{fast}	1 kHz
f_{slow}	30 Hz
T_{Pix}	1.5 μ s
$N_{phot,Pix,APD} (D = 20 \text{ m})$	15900
$N_{phot,Pix,Hybr} (D = 20 \text{ m})$	2.5e6

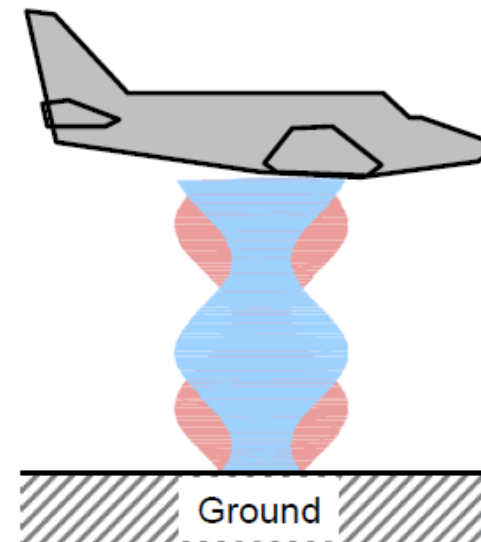
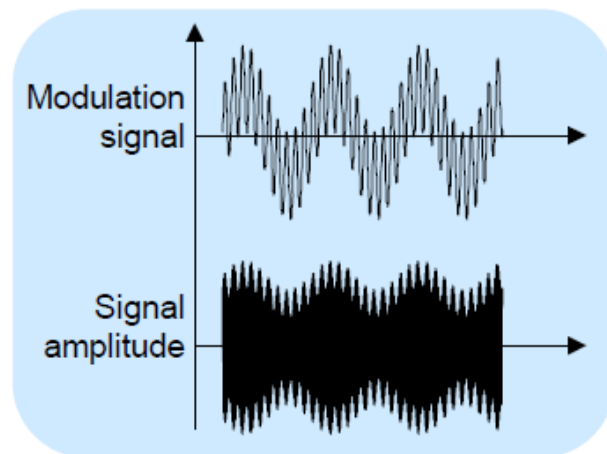
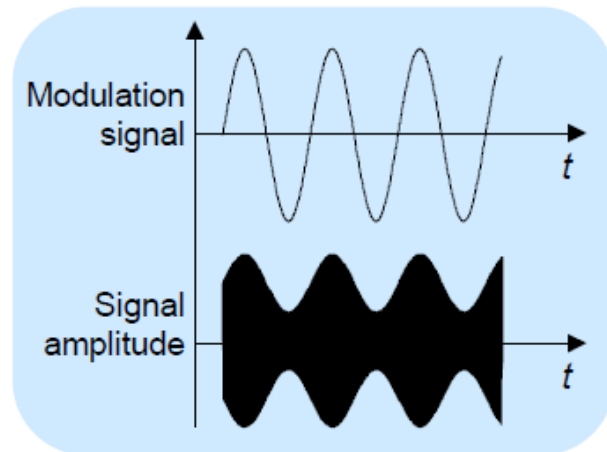


$$\text{SNR}_{\text{phot}} = \frac{N}{\sqrt{N}} = \sqrt{N}$$

Boden Konturvermessung

5

Continuous laser operation



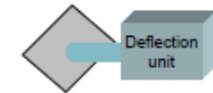
Characteristics (ScaLARS):

- Two modulation frequencies
 $f_{\text{high}} = 10 \text{ MHz}$, $f_{\text{low}} = 1 \text{ MHz}$
 $\rightarrow \lambda_{\text{short}} = 30 \text{ m}$, $\lambda_{\text{long}} = 300 \text{ m}$
- Average power (continuous operation)
 $P_{\text{av}} = 0.26 \text{ W}$

Scan Verfahren



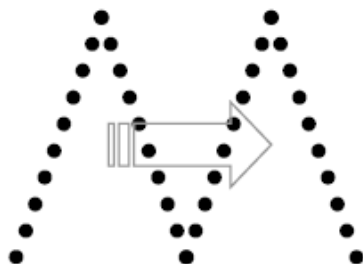
Scanning mechanisms & ground patterns



Oscillating mirror



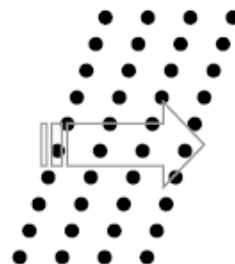
Z-shaped, sinusoidal



Rotating polygon



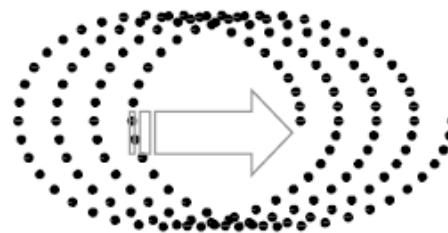
Parallel lines



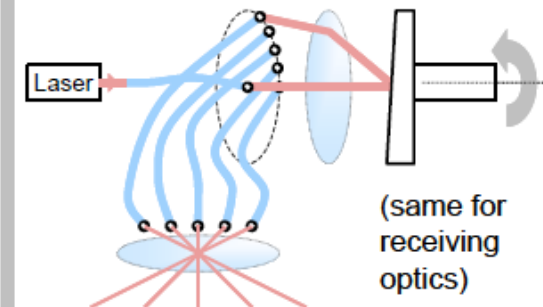
Nutating mirror (Palmer scan)



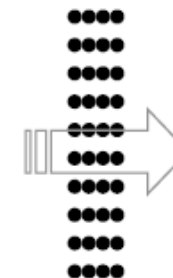
"Elliptical"



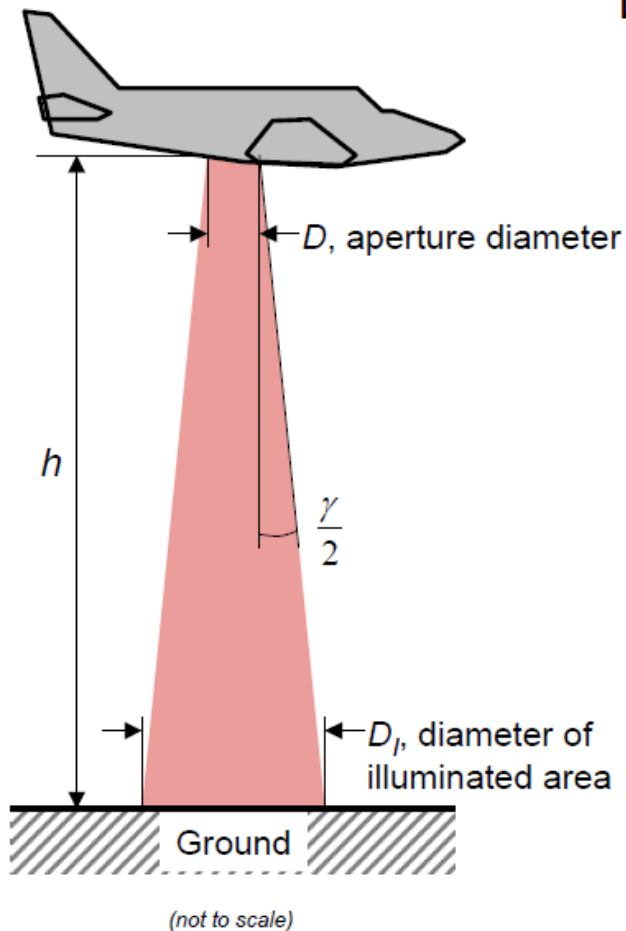
Fiber switch



Parallel lines



Spotgröße am Boden



Beam divergence

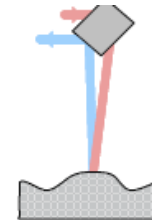
- Laser beam widens with distance
- Beam divergence γ
- Theoretical limit by diffraction $\gamma \geq 2.44 \frac{\lambda}{D}$
- Example:
 $\lambda = 1064 \text{ nm}, D = 10 \text{ cm} \rightarrow 0.026 \text{ mrad}$

- Typical values for ALS:
 $\gamma = 0.3 - 2 \text{ mrad}$

- Ground spot diameter

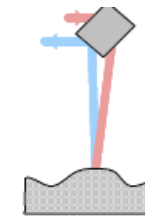
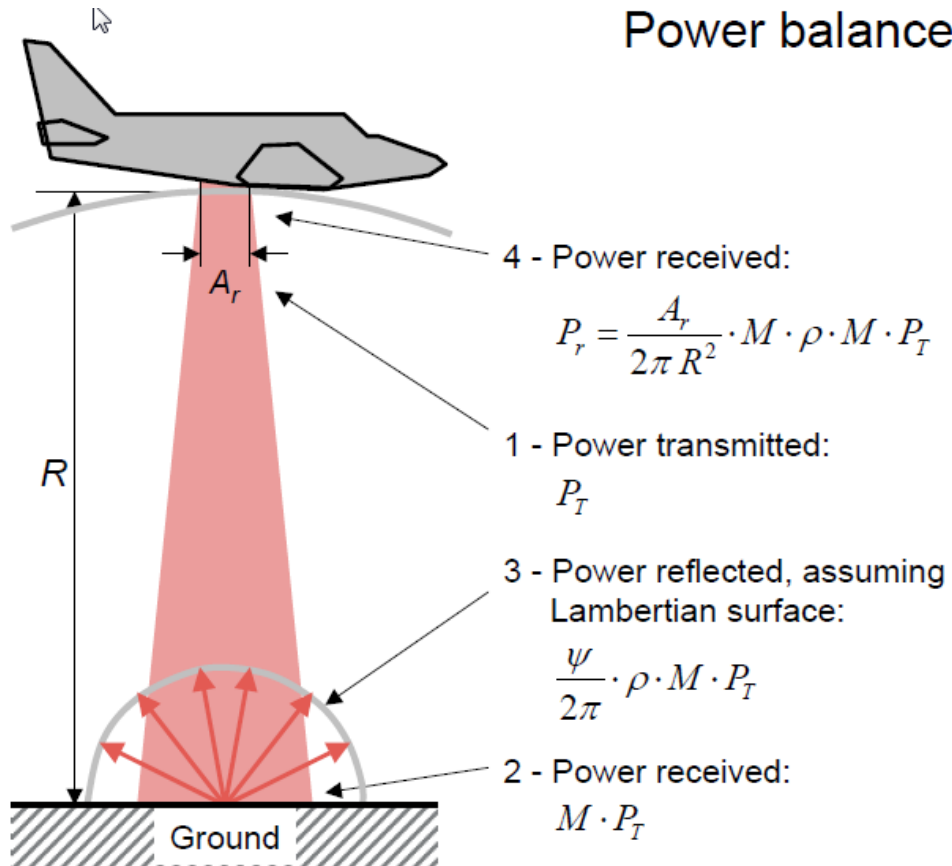
$$\begin{aligned}
 D_I &= D + 2h \tan(\gamma/2) \\
 &\approx 2h \tan(\gamma/2) \\
 &\approx h\gamma
 \end{aligned}$$

- Example:
 $\gamma = 1 \text{ mrad}$
 $\rightarrow 1 \text{ m diameter @ } h = 1 \text{ km flying height}$



Leistungssparameter

Power balance



- $P_T = 2000 \text{ W}$
- Atmospheric transmission $M = 0.8$
- $A_r = 80 \text{ cm}^2$ ($D_r = 10 \text{ cm}$)
- $R = 1 \text{ km}$
- Reflectivity $\rho = 0.5$

$$\rightarrow P_r = 4 \cdot 10^{-10} P_T = 800 \text{ nW}$$

Reflektivität des Bodens

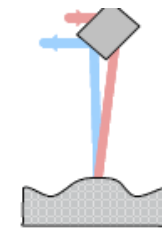
Reflectivity

Reflectivity vs. material

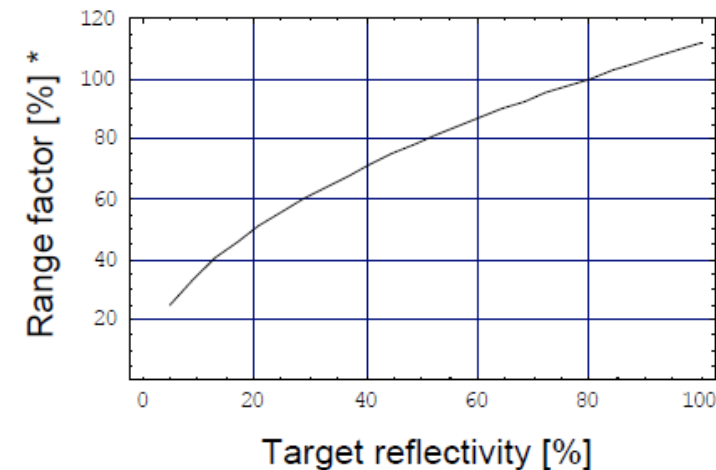
MATERIAL	REFLECTIVITY @ $\lambda = 900 \text{ nm}$
Dimension lumber (pine, clean, dry)	94%
Snow	80-90%
White masonry	85%
Limestone, clay	up to 75%
Deciduous trees	typ. 60%
Coniferous trees	typ. 30%
Carbonate sand (dry)	57%
Carbonate sand (wet)	41%
Beach sands, bare areas in desert	typ. 50%
Rough wood pallet (clean)	25%
Concrete, smooth	24%
Asphalt with pebbles	17%
Lava	8%
Black rubber tire wall	2%

Source: www.riegl.co.at

Range vs. reflectivity



$$P_r = \rho \frac{M^2 A_r}{2\pi R^2} \cdot P_T \Rightarrow R \propto \sqrt{\rho}$$



* Normalized to 100% @ 80% reflectivity

